REMARKS

The following remarks are provided in response to the Office Action ("office action") mailed April 30, 2008 in which the office action:

- objected to claims 1-10 because of informalities.
- rejected claims 1-3, 9-12, and 14 under 35 U.S.C. §103(a) as being unpatentable over US 6,013,399 to Nguyen (hereinafter Nguyen) in view of US 5,429,730 to Nakamura, et al. (hereinafter Nakamura).
- rejected claims 4 and 13 under U.S.C. §103(a) as being unpatentable over Nakamura and Nguyen in view of US 5,916,365 to Sherman (hereinafter Sherman).
- rejected claims 5 and 6 under U.S.C. §103(a) as being unpatentable over

 Nakamura and Nguyen in view of US 6,449,086 to Singh (hereinafter Singh), and
 further in view of US Pub. 2002/0028556 to Marsh, et al., (hereinafter Marsh),
 with reference to US 6,762,072 to Lutz (hereinafter Lutz).
- rejected claims 7 and 8 under U.S.C. §103(a) as being unpatentable over Nguyen,
 Nakamura and Singh in view of US 4,950,498 to Kaito (hereinafter Kaito).
- rejected claim 15 under U.S.C. §103(a) as being unpatentable over Nguyen,
 Nakamura in view of US 5,928,817 to Yan (hereinafter Yan).
- rejected claim 16 under U.S.C. §103(a) as being unpatentable over Nguyen,
 Nakamura in view of US Pub. 2004/0007722 to Narui, et al., (hereinafter Narui).
- rejected claim 17 under U.S.C. §103(a) as being unpatentable over Nguyen,
 Nakamura and Yan in view of US Pub. 2004/0007560 to Sakano, et al.

App. No. 10/723,726 Docket No. 42P17270 Examiner: Vetere, Robert A.
Art Unit: 1792

(hereinafter Sakano).

• rejected claim 18 under U.S.C. §103(a) as being unpatentable over Nguyen,

Nakamura, Yan and Sakano in view of US Pub. 2002/0051846 to Kirkpatrick, et

al. (hereinafter Kirkpatrick).

The Applicants respectfully request reconsideration of the above referenced patent

application for the following reasons:

Objection of claims 1-10 because of informalities

Claims 1-10 are objected to because claim 1 states "in a capping layer to a

chamber." The Examiner believes this should read "...in a chamber."

The Applicants herein amend independent claim 1, from which claims 2-10

depend, and respectfully request reconsideration of claims 1-10 in view of the

amendments.

Claims 1-3, 9-12, and 14 rejection under 35 U.S.C. §103(a)

Claims 1-3, 9-12, and 14 are rejected under 35 U.S.C. §103(a) as being

unpatentable over Nguyen in view of Nakamura. The Applicants herein amend

independent claim 1.

Amended independent claim 1, from which claims 2-3 and 9-10 depend, is

directed at a "method for repairing a defect in an EUV mask" including the elements,

"placing, in a chamber, a multilayer work-piece having a pinhole in a capping layer

thereon," "introducing a precursor gas into the chamber in the immediate area of the

7

App. No. 10/723,726 Docket No. 42P17270 Examiner: Vetere, Robert A. Art Unit: 1792

multilayer work-piece," and "directing an electron beam at the pinhole of the multilayer work-piece to fill the pinhole with a filling material generated from the precursor gas." Independent claim 11, from which claims 12 and 14 depend, includes similar elements. That is, in claims 1-3, 9-12 and 14, the Applicants teach and claim filling, with a filling material, a pinhole in a capping layer of an EUV mask.

The proposed combination of Nguyen and Nakamura fails to disclose filling, with a filling material, a pinhole in a capping layer of an EUV mask. As the office action points out, Nguyen does disclose repairing defects that appear in a capping layer of an EUV mask. (See office action, p. 3, first paragraph.) However, the only defects that Nguyen discloses are either 1) particulate defects on capping layer 43 (see Nguyen, e.g., col. 4, lines 11-13) or 2) uncorrectable defects in an absorbing layer pattern 46 which is disposed above capping layer 43 (see Nguyen, e.g., col. 4, lines 1-3 and Fig. 2.) Thus, Nguyen fails to disclose pinhole defects in a capping layer of an EUV mask or repairing pinhole defects in the capping layer of the EUV mask, as taught and claimed by the Applicants. Instead, the office action relies on Nakamura to disclose "a method of correcting recessed defects (claimed pinholes) in a film." (See office action, p. 3, first paragraph.) However, citing In Re Ratti, the M.P.E.P. states,

"[i]f the proposed modification or combination of the prior art would change the principle of operation of the prior art invention being modified, then the teachings of the references are not sufficient to render the claims *prima facie* obvious." (See M.P.E.P. 2143.01 § VI.)

The proposed combination of Nguyen with Nakamura improperly changes the principle of operation of Nguyen and thus fails to disclose filling, with a filling material, a pinhole

App. No. 10/723,726 Docket No. 42P17270 in a capping layer of an EUV mask.

Specifically, Nguyen discloses removing an entire absorbing layer (and, where appropriate, an entire buffer layer) and depositing a new absorbing layer "to provide a defect free pattern." (*See* Nguyen, e.g., col. 4, line 4 – col. 5, line 7.) That is, the defects on or above the capping layer of Nguyen are removed by removing material (e.g. particulates and/or an absorbing layer) from the surface of the capping layer. On the other hand, Nakamura discloses filling a "divot defect" in a film by adding material to a region of the film to fill the divot defect. (*See* Nakamura, e.g., col. 10, lines 31-49.) If the defects of Nguyen were repaired by the method of Nakamura, then regions of material would be added to portions of the capping layer 43 of Nguyen, instead of material being removed from the surface of the capping layer as disclosed by Nguyen. Thus, the proposed combination of Nguyen and Nakamura is improper because it would change the principle of operation of Nguyen.

Furthermore, for the sake of argument, to the extent that other embodiments of Nakamura do not change the principle of operation of Nguyen, e.g. those embodiments directed at removing a bump defect (*see* Nakamura, e.g., Abstract), then the combination of Nguyen and Nakamura would fail to provide a prima facie rejection of claims 1-3, 9-12 and 14, which are directed at filling a pinhole defect.

Accordingly, the Applicants respectfully request the Examiner to remove the rejection of claims 1-3, 9-12 and 14.

App. No. 10/723,726 Docket No. 42P17270 Claims 4 and 13 rejection under 35 U.S.C. §103(a)

Claims 4 and 13 are rejected under 35 U.S.C. §103(a) as being unpatentable over

Nakamura and Nguyen in view of Sherman. Claim 4 depends from independent claim 1

and claim 13 depends from independent claim 11. The Applicants respectfully request

reconsideration of claims 4 and 13 in view of the above arguments regarding independent

claims 1 and 11.

Claims 5 and 6 rejection under 35 U.S.C. §103(a)

Claims 5 and 6 are rejected under 35 U.S.C. §103(a) as being unpatentable over

Nakamura and Nguyen in view of Singh, and further in view of Marsh, with reference to

Lutz. Claims 5 and 6 depend from independent claim 1. The Applicants respectfully

request reconsideration of claims 5 and 6 in view of the above arguments regarding

independent claim 1.

Claims 7 and 8 rejection under 35 U.S.C. §103(a)

Claims 7 and 8 are rejected under 35 U.S.C. §103(a) as being unpatentable over

Nguyen, Nakamura and Singh in view of Kaito. Claims 7 and 8 depend from

independent claim 1. The Applicants respectfully request reconsideration of claims 7 and

8 in view of the above arguments regarding independent claim 1.

Claim 15 rejection under 35 U.S.C. §103(a)

Claim 15 is rejected under 35 U.S.C. §103(a) as being unpatentable over Nguyen,

App. No. 10/723,726 Docket No. 42P17270 Examiner: Vetere, Robert A.

10

Nakamura in view of Yan. Claim 15 depends from independent claim 11. The

Applicants respectfully request reconsideration of claim 15 in view of the above

arguments regarding independent claim 11.

Claim 16 rejection under 35 U.S.C. §103(a)

Claim 16 is rejected under 35 U.S.C. §103(a) as being unpatentable over Nguyen,

Nakamura in view of Narui. Claim 16 depends from independent claim 11. The

Applicants respectfully request reconsideration of claim 16 in view of the above

arguments regarding independent claim 11.

Claim 17 rejection under 35 U.S.C. §103(a)

Claim 17 is rejected under 35 U.S.C. §103(a) as being unpatentable over Nguyen,

Nakamura and Yan in view of Sakano. Claim 17 depends from independent claim 11.

The Applicants respectfully request reconsideration of claim 17 in view of the above

arguments regarding independent claim 11.

Claim 18 rejection under 35 U.S.C. §103(a)

Claim 18 is rejected under 35 U.S.C. §103(a) as being unpatentable over Nguyen,

Nakamura, Yan and Sakano in view of Kirkpatrick. Claim 18 depends from independent

claim 11. The Applicants respectfully request reconsideration of claim 18 in view of the

above arguments regarding independent claim 11.

App. No. 10/723,726

11 Examiner: Vetere, Robert A. Docket No. 42P17270 Art Unit: 1792 **CONCLUSION**

The Applicants submit that they have overcome the office action's objections to

and rejections of the claims and that they have the right to claim the invention as set forth

in the listed claims. The Examiner is respectfully requested to contact the undersigned by

telephone if it is believed that such contact would further the examination of the present

application.

Pursuant to 37 C.F.R. 1.136(a)(3), the Applicant(s) hereby request and authorize

the U.S. Patent and Trademark Office to (1) treat any concurrent or future reply that

requires a petition for extension of time as incorporating a petition for extension of time

for the appropriate length of time and (2) charge all required fees, including extension of

time fees and fees under 37 C.F.R. 1.16 and 1.17, to Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY SOKOLOFF TAYLOR & ZAFMAN, L.L.P.

July 30, 2008

Date

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App. No. 10/723,726 Docket No. 42P17270 Examiner: Vetere, Robert A.
Art Unit: 1792